



#10/Response
**BOX AFTER FINAL
EXPEDITED PROCEDURE** *(14)*
740756-002077

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Shunpei YAMAZAKI et al.

Application No.: 09/466,828

Filed: December 20, 1999

For: INSULATING FILM AND
METHOD OF PRODUCING
SEMICONDUCTOR DEVICE

Art Unit: 2818

Examiner: Renee BERRY

6/18/01
Smith
RECEIVED
JUN 18 2001
TC 2800 MAIL ROOM

AMENDMENT AFTER FINAL

*OK to enter
MAB*
Commissioner of Patents
Washington, D.C. 20231

June 13, 2001

Dear Sir:

In response to the Examiner's Final Office Action mailed February 13, 2001, the period for response having been extended one (1) month, please consider the following amendments and remarks in connection with the above-identified application.

REMARKS

At the outset, the Examiner is thanked for the thorough review and consideration of the present application.

The Examiner's Final Office Action dated February 13, 2001, has been received and its contents reviewed. Claims 1-29 were pending in the present application prior to the instant amendment. Subsequently, claims 1-29 are pending, of which claims 1, 8, 13, 17, and 25 are independent.

Referring now to the Office Action, claims 1-29 stand rejected under the judicially created doctrine of double patenting allegedly over claims 1-27 of U.S. Patent No. 5,821,138. This rejection is respectfully traversed.

The Office utilized Form Paragraph 8.38, such as outlined in MPEP 804 (7th Edition Rev. 1), pages 800-21 to 800-23, to support the rejection. However, Applicants respectfully